



**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q67940

Masaki KURIHARA, et al.

Appln. No.: 10/035,137

Group Art Unit: 1752

Confirmation No.: 3139

Examiner: John Chu

Filed: January 04, 2002

For: POSITIVE PHOTORESIST COMPOSITION

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**AMENDMENT UNDER 37 C.F.R. § 1.111**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated March 27, 2003, please amend the above-identified application as follows on the accompanying pages.

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